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| Notice of References Cited | Application/Control No. 10/656,845 | Applicant(s)/Patent Under Reexamination KIM, JUNG TAE | |
| | Examiner Jiping Lu | Art Unit 3749 | Page 1 of 1 |

U.S. PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Name | Classification |
|---|---|--|-----------------|-----------------------|----------------|
| | A | US-6,135,762 | 10-2000 | Hu, Ke Ren | 431/153 |
| | B | US-6,663,383 | 12-2003 | Jon, Jong-Koo | 431/153 |
| | C | US-6,722,877 | 04-2004 | Wang et al. | 431/153 |
| | D | US-6,739,867 | 05-2004 | Puig-Gros, Juan Lucas | 431/153 |
| | E | US-2003/0143504 | 07-2003 | Chung, Aman Kai man | 431/153 |
| | F | US- | | | |
| | G | US- | | | |
| | H | US- | | | |
| | I | US- | | | |
| | J | US- | | | |
| | K | US- | | | |
| | L | US- | | | |
| | M | US- | | | |

FOREIGN PATENT DOCUMENTS

| * | | Document Number Country Code-Number-Kind Code | Date MM-YYYY | Country | Name | Classification |
|---|---|--|-----------------|---------|------|----------------|
| | N | | | | | |
| | O | | | | | |
| | P | | | | | |
| | Q | | | | | |
| | R | | | | | |
| | S | | | | | |
| | T | | | | | |

NON-PATENT DOCUMENTS

| * | | Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages) |
|---|---|---|
| | U | |
| | V | |
| | W | |
| | X | |

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